

# A Microwave Channelizer and Spectroscope Based on an Integrated Optical Bragg-Grating Fabry–Perot and Integrated Hybrid Fresnel Lens System

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**Abstract**—A compact means to separate microwave and millimeter-wave optical signals by RF frequency in real time is demonstrated. The approach is to employ an integrated optical Bragg grating Fabry–Perot (BGFP) device to spatially separate optically modulated microwave signals with high resolution. The compactness is achieved through the use of an integrated optical hybrid diffractive lens beam expander to provide the required optical wavefront to the BGFP. A proof-of-principle measurement was performed from 1 to 23 GHz with peak finesse of 27. The theoretical analysis, fabrication procedure, experimental results, limitations, and improvements are described.

**Index Terms**—Fabry–Perot interferometers, optical planar waveguide components, optical signal processing, microwave receivers.

## I. INTRODUCTION

**R**F SIGNALS may be separated into many contiguous parallel channels using optical demultiplexers with high resolving power. These devices are described as channelizers, and have applications such as microwave signal estimation [1]. Such separation of a wide microwave spectrum into smaller frequency channels provides continuous spectral coverage suitable for electronic analog-to-digital conversion [2]. Apart from microwave channelizers, such devices are envisaged for ultra-narrow wavelength division multiplexing (WDM) [3], real-time optical spectrum analysis [4], and wavelength references [5]. Many optical channelizer approaches have been attempted. Acousto-optic channelizers are limited to below a few gigahertz due to phonon scattering, but have been demonstrated in integrated optical form [6], [7]. Integrated magneto-optic devices such as presented in [8] offer higher frequencies of operation at the expense of narrow bandwidth and high microwave drive levels. Passive integrated optical devices such as Bragg gratings, ring resonators, and Mach–Zehnder interferometers

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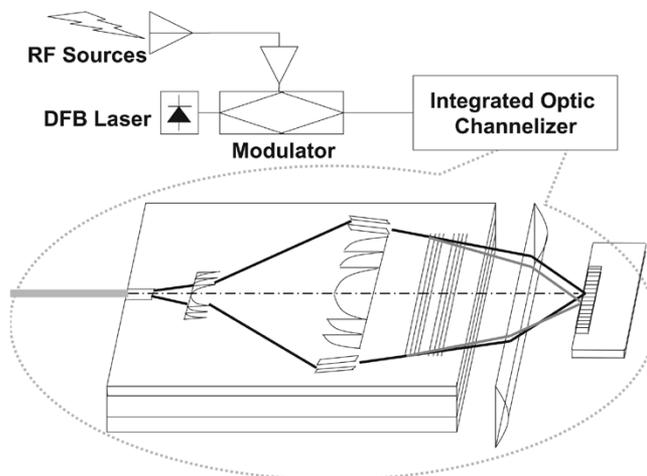


Fig. 1. Channelizer architecture.

might appear suitable for such applications. These devices, however, are limited in resolving power [9], cascaded power loss in reflection [10], interferometer limitations [11], complex optical post-tuning steps [12]–[14], and bulky classical optical implementation [15], [16]. Recent developments in the literature show a possibility of resolving power and small footprint attributable to multibeam interferometers [17], [18]. The approach described in this paper is based upon spatial wavelength demultiplexing using the Fabry–Perot etalon [19]. Early studies have demonstrated the feasibility of this approach, but in bulky classical optical form [20], [21].

The authors present for the first time a compact integrated optical channelizer based on a Bragg grating Fabry–Perot (BGFP) etalon. The incident wavefront to the Fabry–Perot is diffracted by integrated optical hybrid lens structures. The device is compact, is easy to mass produce, and has the potential for high resolving power and wide microwave bandwidth.

## II. SYSTEM DESCRIPTION

### A. BGFP Channelizer

The architecture is depicted in Fig. 1. A wide-band electro-optical modulator allows a microwave or millimeter-wave signal to modulate an optical carrier that is delivered via fiber to the integrated optical device. In this device, the optical phase front is expanded and the integrated optical lens system causes this signal to diverge laterally. A Fabry–Perot etalon

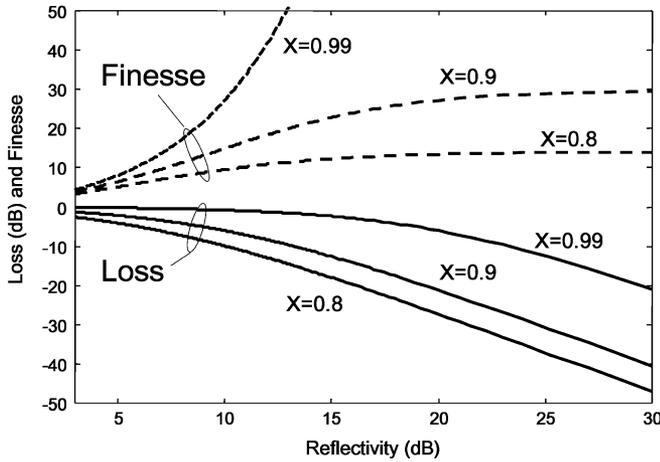


Fig. 2. Loss and finesse versus reflectivity.

formed with two Bragg gratings acts upon this wavefront to create a resonance condition that is now a function of angle and wavelength—thus providing microwave channelization.

An array of low-speed photodetectors at the focal plane then provides  $N$  frequency resolved outputs. Wide bandwidth microwave and millimeter-wave operation is possible since the modulation and dispersion functions are separate. Modulation over 40 GHz with low-drive power is possible [22], and 100 channels are feasible based on published Fabry–Perot performance [23].

### B. Departure From Ideal Performance

The relationship between the number of channels and the microwave bandwidth is defined by the Fabry–Perot *finesse*, typically 10–100 in the etalon configuration. Reduced finesse directly reduces the RF frequency resolution. Physical effects impacting on the BGFP finesse are, therefore, analyzed here. The BGFP is made up of wavelength-dependent reflectors and contains a lossy cavity element—these departures from ideal performance place a limit on the finesse achievable. To this end, the ideal power transmission through the BGFP can be described in terms of a wavelength-dependent reflectivity  $R(\delta)$  and a single-pass cavity transmission  $X$  as

$$P_{X,R}(\delta) = \frac{X(1 - R(\delta))^2}{(1 - XR(\delta))^2 + 4R(\delta)X \sin^2(\delta/2)} \quad (1)$$

where  $\delta$  is a dispersion detuning parameter dependent on wavelength, cavity spacing, and angle into the etalon [21]. Fig. 2 illustrates the loss and resultant finesse associated with a practical device and, therefore, the upper limit on reflectivity if  $X$  is known. It should be noted that this loss is in addition to the fundamental loss that occurs due to spreading of the incident beam into angular resolution elements.

Other effects have the potential to reduce the frequency resolution. Fortunately the incident angle to the Bragg grating is insufficient to reduce the reflection dramatically [24]. In a classical etalon, finesse is limited by defects such as dust, pressure, and etalon plate flatness and curvature. In the integrated optical device, these defects manifest as spatial variation of the Bragg

condition, misalignment of the Bragg grating during manufacture, and group-delay ripple across the transverse aperture of the BGFP. An expression for the variation of the effective reflection point can, therefore, be derived as

$$\delta_t = \sqrt{\frac{0.22(d\delta\nu)^2}{\nu_o^2} - \left[ \frac{\lambda^2(1-R)^2}{180R} - \frac{\lambda^2}{D^2} \left\{ 0.22d^2\theta^2 + \frac{0.08\lambda d}{m} \right\} \right]} \quad (2)$$

where  $\nu_o$  is the optical frequency,  $\delta\nu$  is the required RF resolution,  $D$  is the etalon aperture,  $d$  is the cavity spacing,  $R$  is the nominal reflectivity,  $\lambda$  is the free-space wavelength, and  $m$  is the etalon order. It is assumed that each defect contribution has an equal peak excursion across the aperture, as it is unknown what the contributing effect is *a priori*. Thus, a system finesse independent of the BGFP defects would require a peak variation of the reflection point across the aperture of less than 10 nm. This level of fabrication tolerance is difficult to obtain even for a uniformly written interferometric structure.

### C. Integrated Optical Lens System

The integrated optical lens system is a means to provide the required phase front to the BGFP in a compact and easily fabricated form. Geometric optics were used in the design of an integrated optical Galilean telescope to expand the beam, and the individual lenses were hybrid diffractive structures designed following [25]. The hybrid structure consists of analog Fresnel regions near the lens center and zone plates where the feature size is less than 2  $\mu\text{m}$ .

## III. DESIGN AND FABRICATION

The integrated optical channelizer was fabricated in flame-hydrolysis silica on silicon material. The lenses and waveguides were formed by reactive ion etching to 2  $\mu\text{m}$  and the BGFP was constructed by narrow spatial scanning of a UV beam through a phase mask. The substrate was hypersensitized with 193-nm light to enhance sensitivity and overcome the out diffusion of hydrogen, an approach pioneered in [26]. Post-exposure of the grating was used to align the Fabry–Perot resonance to the peak reflectivity wavelength. The BGFP structure was limited to approximately 10-mm length (including the 1-mm cavity) and a 25-mm aperture to reduce beam walkoff, necessitating a peak reflectivity of approximately 23 dB and an unwanted free spectral range of 150 GHz (40 GHz is preferred, matched to the modulator bandwidth). All other components of the system were standard microwave photonic parts. The waveguide effective index and scalar mode profile were calculated using the eigenvalue solution of Maxwell's equations [27]. An overlap integral method was then used to determine the loss of the lens structures and the focal plane distribution and efficiency were calculated based upon diffraction theory [28]. The BGFP resonance wavelength and bandwidth were calculated based on a numerical implementation of the transfer matrix method (TMM) assuming a single TE polarization and minimal angular dependence [29].

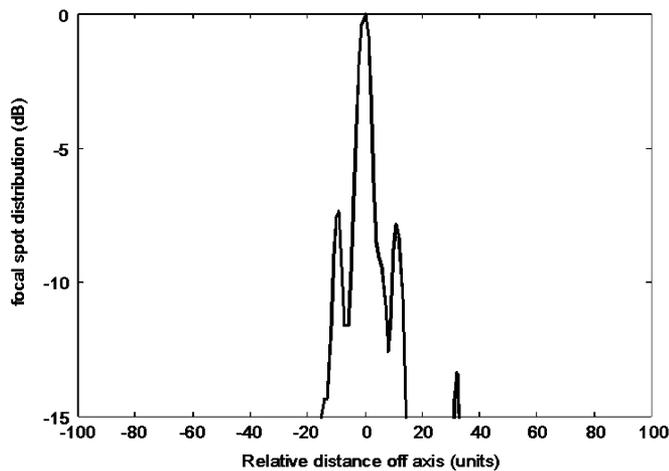


Fig. 3. IO Lens focal plane distribution.

#### IV. EXPERIMENTAL RESULTS

##### A. Integrated Optical Lens System

The focal plane distribution and diffraction efficiency were measured at a wavelength near, but not equal to, the BGFP resonance. The focal point was 103 mm as designed to within experimental error. The sidelobe level and diffraction efficiency were lower than expected values of  $-8$  dB and 58%. The etch depth was measured with a profilometer and the etch depth difference is sufficient to account for the discrepancy between design and fabricated values. The focal plane distribution is shown in Fig. 3. Overall, the lens system is an effective means of providing a compact high-efficiency and wide aperture wavefront to the BGFP.

##### B. Spectral–Spatial Measurement

Two significant loss mechanisms are apparent in the form of (1): the effect of intracavity loss in the presence of wavelength-dependent reflectivity and the loss associated due to the spreading of the optical power into angular resolution elements. These two effects were found to significantly limit the performance achievable and, thus, a means of calculating the loss contributions from these effects was devised [30]. The spatial distribution of the unmodulated optical signal was measured as a function of laser wavelength. This two-dimensional (2-D) measurement was then reduced to the loss versus wavelength graph shown in Fig. 4 using an approach described in detail in [29].

From the measurements, a single-pass cavity transmission of only  $X = 0.9$  is estimated, not excessive, but illustrating the significant detrimental effect on the overall loss in excess of 25 dB at the peak wavelength. In addition, the fundamental loss of 15 dB is due to angular power spreading in the Fabry–Perot device. These two loss mechanisms place a limit on the performance that can be achieved with the current design, but provide understanding on how to improve the system frequency resolution.

##### C. RF Channelizer Demonstration

A channelizer demonstration was nevertheless performed to prove the principle of the integrated optic BGFP as a microwave channelizer. In this measurement, the frequency resolution is

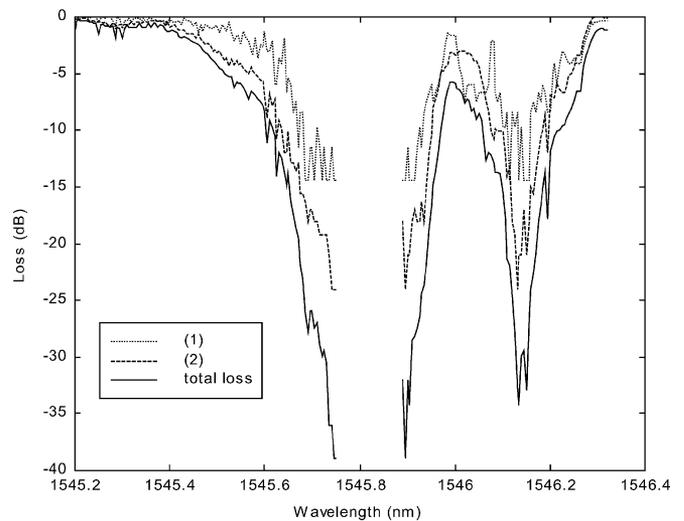


Fig. 4. BGFP loss via spectral spatial measurement. (1) Loss due to angular power spreading. (2) Loss due to intracavity loss/wavelength dependent reflectivity.

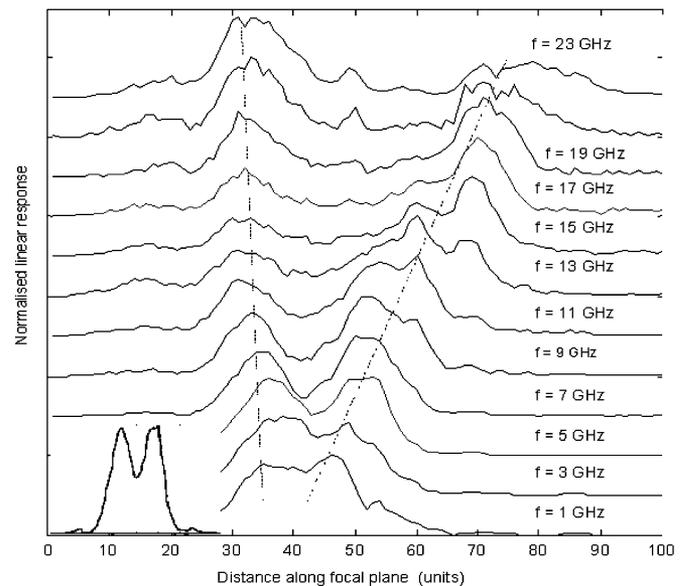


Fig. 5. Microwave sidebands at focal plane (linear distance units). Inset: sidebands at 5 GHz.

determined by measuring the optically modulated microwave sideband finesse as a function of RF frequency. The modulator was biased at a null to effect double-sideband suppressed carrier (DSB-SC) operation [19], and the laser wavelength was aligned to the point of peak reflectivity. The RF frequency was varied from 1 to 23 GHz so that the sidebands would be spatially demultiplexed across the whole Bragg grating bandwidth. The focal plane intensity distribution was recorded and the results are depicted in Fig. 5. The inset shows the two sideband channels measured at the focal plane for frequency of 5 GHz.

The finesse and loss as a function of RF center frequency are depicted in Fig. 6. The lower sideband has a larger angular dispersion than the upper sideband, which has been noticed in previous experiments [19], and results from the conversion of angular response to the focal plane via the transform lens. The frequency resolution is severely limited by effects described in Sec-

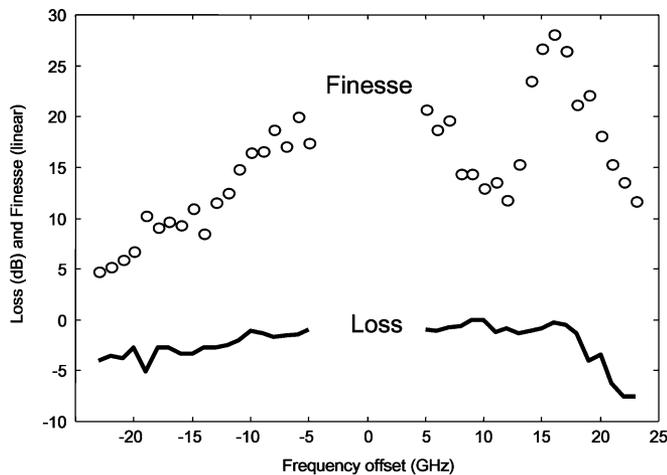


Fig. 6. Finesse and relative loss versus frequency.

tion II-B, but the peak finesse of 27 correlates well between the two measurements. Future designs should take the intracavity loss and wavelength dependent reflectivity into account. Nevertheless, proof-of-principle channelization has been achieved and frequency results are comparable to previous optical channelizer demonstrations in bulk optical form [31].

#### V. IMPROVEMENTS

The device as demonstrated does not have the resolution expected of a high-performance microwave channelizer. However, the measurements and analysis have provided design insight suitable for such a system. Accurately etching the lens depth or moving to a photosensitive lens [32] will improve the diffraction efficiency and make device fabrication a simple photosensitivity “printing” process. Slight improvements can also be made by tilting the zone plates to maximize efficiency [33]. Extending the phase mask travel to provide a 3.75-mm cavity will reduce the free spectral range to 40 GHz and, thus, increase the frequency resolution by a factor of four. However, the significant loss mechanism was determined to be intracavity loss in the presence of high reflectivity. Increasing the single-pass cavity transmission slightly and matching the required reflectivity will significantly improve performance. Cavity loss can be reduced further with gain in the cavity via erbium-glass materials [34] and, finally, multicavity effects to improve the resolution [35]. The results demonstrated in this study demonstrate the possibility of a channelizer with 40 channels, each with 1-GHz bandwidth covering a 40-GHz range in compact integrated optical form, less than 1500 mm<sup>3</sup> in volume.

#### VI. CONCLUSION

A means for spatially separating optically modulated RF signals has been described. The method is based on the use of a compact integrated optical BGF to provide the angular dispersion required for high resolving power of microwave sideband signals. The required input wavefront to the BGF is provided through the use of a wide aperture hybrid Fresnel lens system integrated onto the substrate. Expressions for the performance limitations of such a device have been derived and a design has been detailed.

The loss mechanisms attributable to the device has been measured and analyzed by a spectral-spatial measurement at the focal plane of the device. Finally, the operation as a channelizer has been demonstrated via a modulated microwave spatial demultiplexing experiment. The etalon finesse varied from 27 to 5 over a 46-GHz spectral range. Suggested limitations and advantages of the approach have been described and the expected performance for a subsequent iteration has been quantified.

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